Searcn Notes			

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/652,496	OHASHI ET AL.	
Examiner	Art Unit	
Chau Nguyen	2176	

SEARCHED				
Class	Subclass	Date	Examiner	
715	517	1/27/2006	CN	
715	520	1/27/2006	CN	
715	507	1/27/2006	CN	
715	505	1/27/2006	CN	
715	908	1/27/2006	CN	

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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SEARCH NO (INCLUDING SEARCI)
	DATE	EXMR
East Reports	01/26/2006	CN
	1/27/2006	CN
	1/30/2006	CN
NPL Search on IEEE Database	1/30/2006	CN